



Fig. 8. (a) Simulated ($\lambda = 1550$ nm) lowest-loss single-mode core geometry and (b) aspect ratio are plotted versus bend radius.

5. Conclusions

An ultra-low-loss planar waveguide technology is demonstrated to bring the performance advantages of optical fiber-based devices to the chip scale. Although several low-index-contrast ($\Delta n = 0.5 - 2.5\%$) technologies are also good ultra-low loss candidates, stoichiometric LPCVD Si_3N_4 , with an index contrast of $\sim 25\%$, offers the additional benefits of increased material uniformity and stability. Using a high-aspect-ratio core geometry, ultra-low loss can be obtained in single-mode Si_3N_4 waveguides at bend radii as low as 0.2 mm. In this work, we demonstrate record low losses of 8-9, 5, 3.5, and 3 dB/m at 0.5, 1, 1.5, and 2 mm bend radii, respectively. The challenge of measuring ultra-low loss with sufficient accuracy at chip-scale propagation lengths is met using ring resonator and OFDR techniques.

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